173/

TRANSMITTAL LETTER (General - Patent Pending) P F				Docket No. RDP101US		
(General - Latent Lending)						
In Re Application Of: Michael P. Dunn et al.						
Application No.	Filing Date	Examine & TRADEMAN	Customer No.	Group Art Unit	Confirmation No.	
10/047,893	January 14, 2002	Sean E. Vincent	24041	1731	5453	
Title: METHOD FOR MAKING A SILICONE CARBIDE RESISTOR WITH SILICON / SILICON CARBIDE						
BY INDUCTION HEATING						
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COMMISSIONER FOR PATENTS:						
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cc:				Michael L. Dunn		

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STATES PATENT AND TRADEMARK OFFICE

U.S. Patent Application No.: 10/047,893

Confirmation No.: 5453

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and is addressed to the Commissioner for Patents, PO

Applicant(s): Michael P. Dunn et al.

Filed: January 14, 2002

For: METHOD FOR MAKING A SILICONE

CARBIDE RESISTOR WITH SILICON /

SILICON CARBIDE CONTACTS BY INDUCTION HEATING

TC/Art Unit: 1731

Examiner: Sean E. Vincent

RDP101US Docket No.:

Customer No.:

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24041

REPLY TO RESTRICTION REQUIREMENT

Mail Stop Amendment Commissioner for Patents PO Box 1450 Alexandria, VA 22313-1450

Honorable Sir:

This is a Reply to the Restriction Requirement dated October 5, 2004, restricting the claims to Group I, Claims 1-13 for a method for bonding silicon carbide and Group II, claims 14-16 drawn to our induction heating apparatus.

Applicants elect Group I claims 1-13 for examination without traverse.

Respectfully submitted,

Mutul

Michael L. Dunn

Registration No.25,330

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Dated: November 5, 2004